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In re Application of:

JOYCE S. OEY HEWETT ALEXANDER J. PASADYN

Serial No.: 09/909,112

Filed: July 19, 2001

For: USE OF SLURRY WASTE

COMPOSITION TO DETERMINE THE AMOUNT OF METAL REMOVED DURING CHEMICAL MECHANICAL POLISHING, AND SYSTEM FOR

ACCOMPLISHING SAME

Examiner: Lynette T. Umez Eronini

Group Art Unit: 1765

Att'y Docket: 2000.089100/TT4642

Customer No.: 23720

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## **RESPONSE TO OFFICE ACTION DATED JULY 8, 2003**

CERTIFICATE OF MAILING 37 C.F.R 1.8

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

Sir:

October 6, 2003

This paper is submitted in response to the Office Action dated July 8, 2003, for which the three-month date for response is October 8, 2003.

A fee in the amount of \$90.00 is believed to be due in connection with the present paper.

The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R.

§§ 1.16 to 1.21, from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT4642.

In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.089100.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.

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